

First successful demonstration of operating a helium gas cooled pixel detector



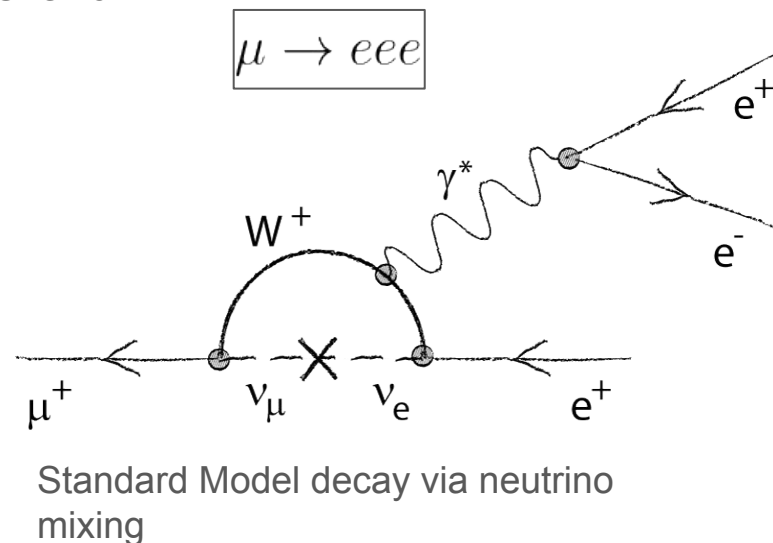
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Frank Meier Aeschbacher - Paul Scherrer Institut
FTDM 2022 - 08.06.2022





Probing the Standard Model with Mu3e

- Mu3e is a high-precision experiment at PSI, Switzerland
- $\mu \rightarrow eee$ in SM including neutrino mixing
 - ➔ $\text{BR}(\mu \rightarrow eee) < 10^{-54}$
 - ➔ beyond observable levels
- New physics might enhance BR by several orders
- Current limit:
 $\text{BR}(\mu \rightarrow eee) < 10^{-12}$ (SINDRUM, 1988)
- Aimed single-event sensitivity:
 $\text{BR}(\mu \rightarrow eee) < 2 \cdot 10^{-15}$ (Phase 1)
 $\text{BR}(\mu \rightarrow eee) < 10^{-16}$ (Phase 2)





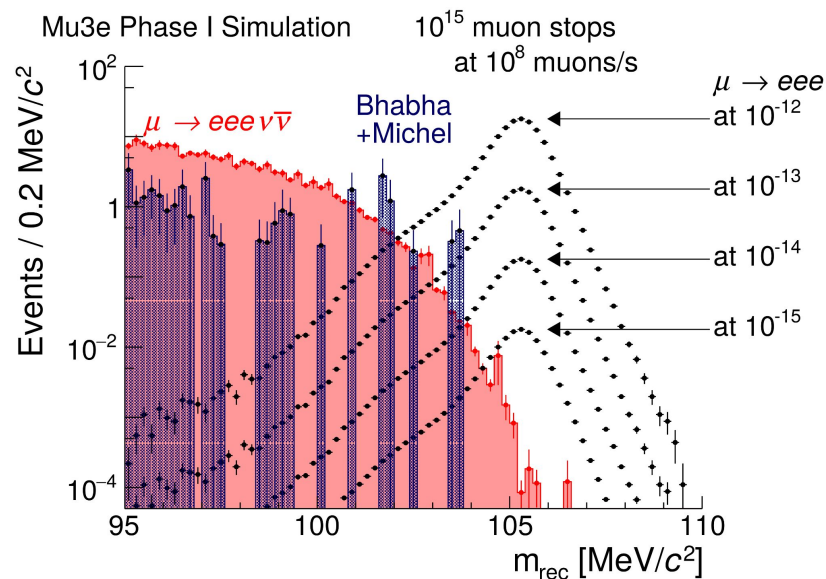
Experimental challenges

- High rates ($\geq 10^8 \mu^+$ decays per second)
- Low-momentum particles
 - Muons decay at rest
 - Electron/Positron momenta $< 53 \text{ MeV}/c$
- Signal-to-background discrimination
 - $\mu \rightarrow eee\nu$ (main background channel)
 - Limited by multiple-Coulomb scattering
 - Accidental background

➔ low material budget

➔ fast detectors

➔ high granularity



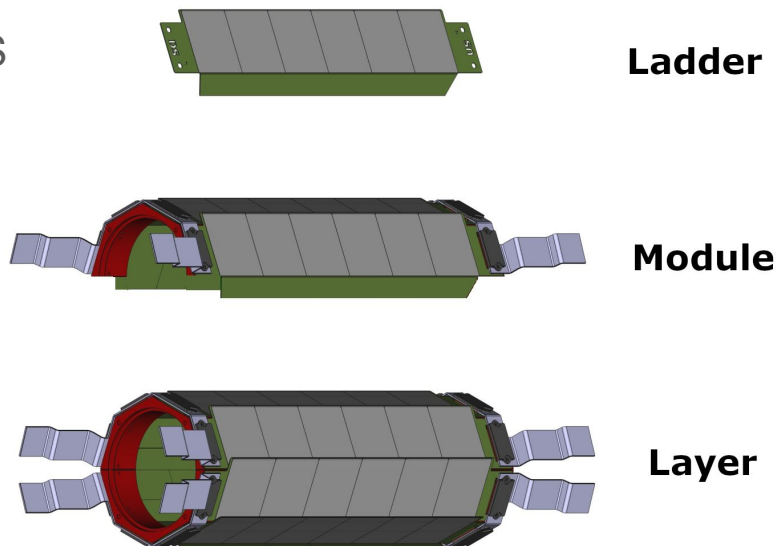
Invariant mass of signal decay, radiative decay and accidental background (Bhabha+Michel) [[Mu3e TDR](#)]



Low material budget

Detector ladders:

- High-density interconnect (HDI) + HV-MAPS
- $X/X_0 \approx 1.15 \text{ ‰}$ per tracking layer
- $\approx 80 \text{ }\mu\text{m}$ laminates (HDI)
- $50 \text{ }\mu\text{m}$ thin pixel chips ($2 \times 2.3 \text{ cm}^2$ area)



Composition of a Mu3e vertex detector layer



Low material budget

Cooling:

- HDIs:
 - serve as support
 - host lines for LV, HV, chip configuration and signals
- only missing: infrastructure for cooling



Low material budget

Cooling:

- HDIs:
 - serve as support
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Concept:

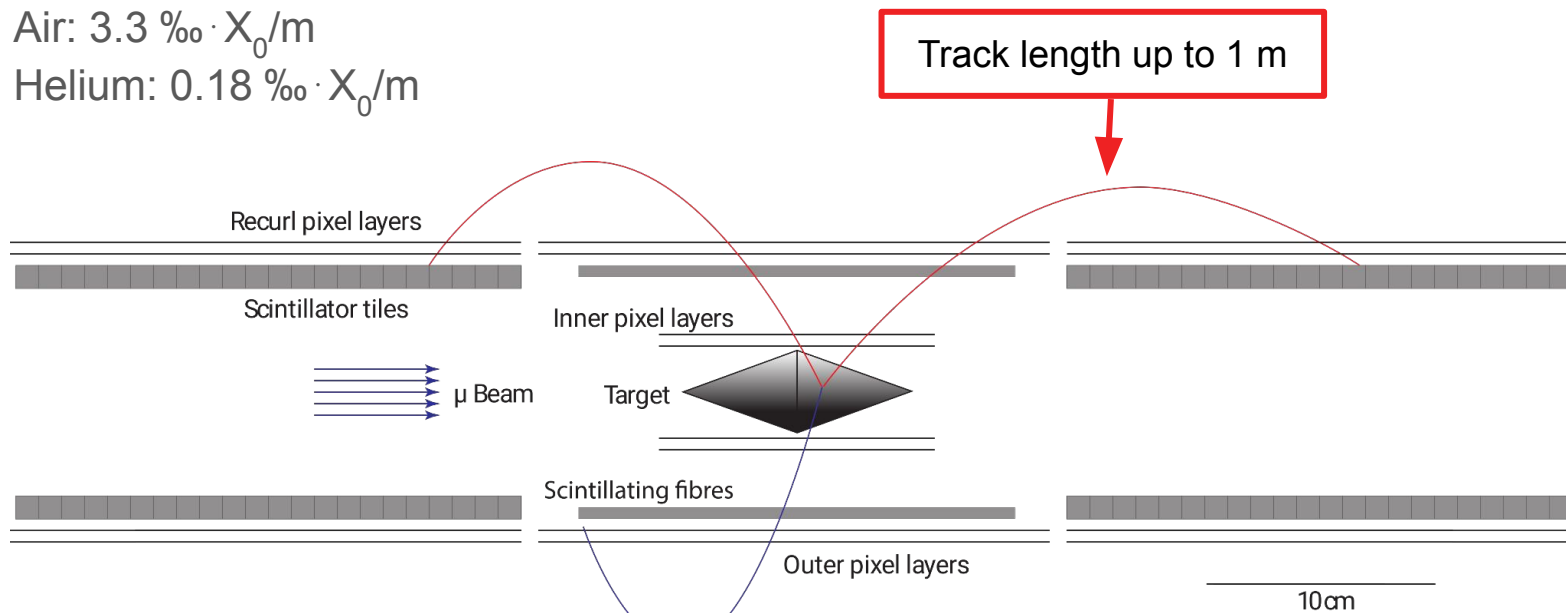
- gaseous cooling → little material
- flow channels confined by tracking layers themselves → no additional material



Low material budget

Cooling gas:


- Air: $3.3 \text{ ‰} \cdot X_0/\text{m}$
- Helium: $0.18 \text{ ‰} \cdot X_0/\text{m}$

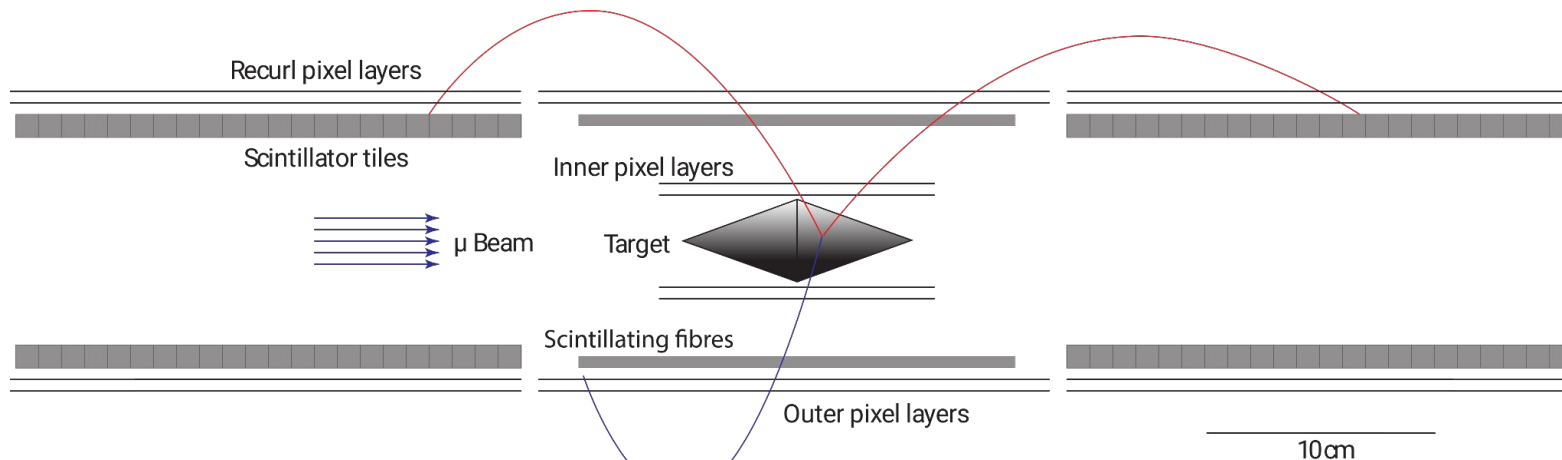




Low material budget

Cooling gas:

- ~~Air: 0.33 % $\cdot X_0/m$~~  corresponds to around 3 tracking layers
- **Helium: 0.018 % $\cdot X_0/m$**





Gaseous helium cooling

	Air	N ₂	Ne	He	H ₂	unit	
density	ρ	1.29	1.25	0.90	0.18	0.09	kg/m ³
	X ₀	3.0×10^4	3.3×10^4	3.5×10^4	5.7×10^5	7.5×10^5	cm
	X/X ₀	0.33	0.30	0.29	0.018	0.013	% (for X = 1 m)
Thermal conductivity	λ	0.241	0.24	0.46	1.43	1.71	mW/(cm·K)
volumetric heat capacity	C _p	1.01	1.04	1.03	5.23	14.32	kJ/(kg·K)
	s	1.30	1.30	0.93	0.94	1.29	kJ/(m ³ ·K)



Gaseous helium cooling

- high thermal conductivity
 - average heat capacity
 - despite low density
- ➔ **Gaseous helium offers not only a high radiation length but also acts as an good coolant!**

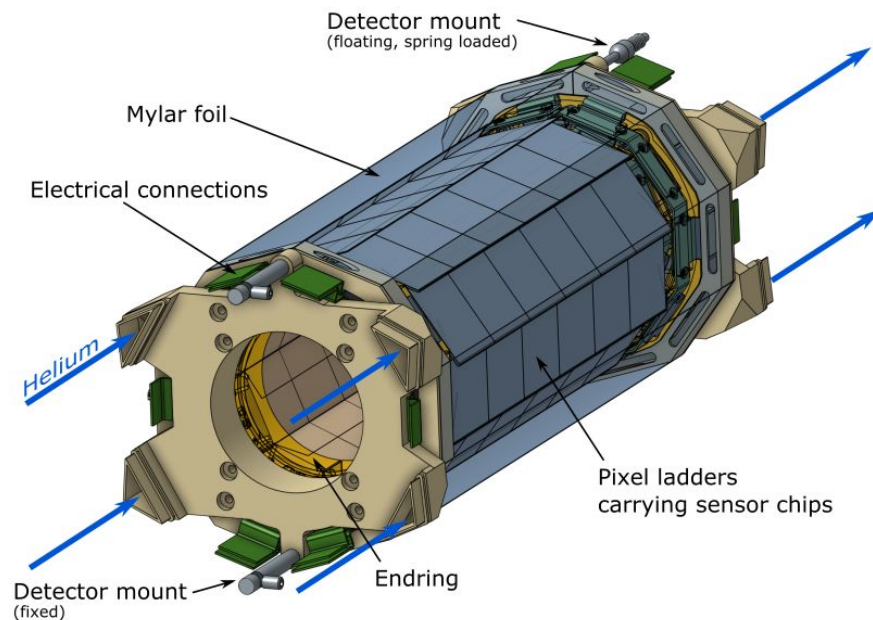
Specs:

- $T_{\text{chip}} < 70^{\circ}\text{C}$ for an inlet temperature of $\sim 0^{\circ}\text{C}$
- glass transition temperature of adhesives used



Mu3e vertex detector

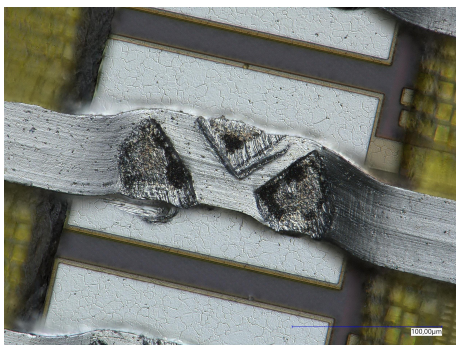
- inner two tracking layers
- Layer 0
 - 8 ladders (48 MuPix chips)
 - $r = 23.3$ mm
- Layer 1
 - 10 ladders (60 MuPix chips)
 - $r = 29.8$ mm
- 2 helium flow channels
 - between L0/L1
 - around L1, confined by Mylar foil
- estimated heat dissipation 215 mW/cm²
- system designed to cool up to 350 mW/cm²



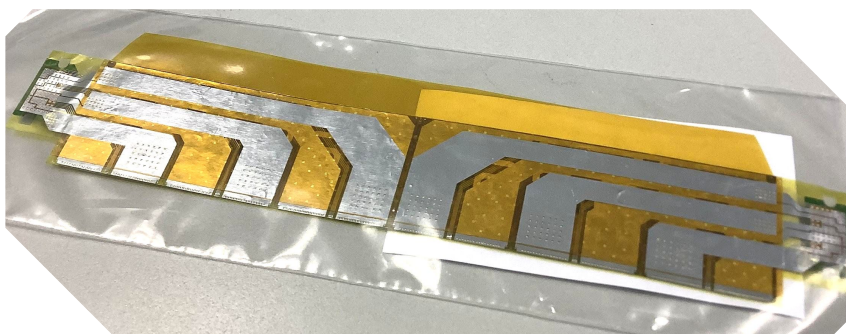


Cooling tests

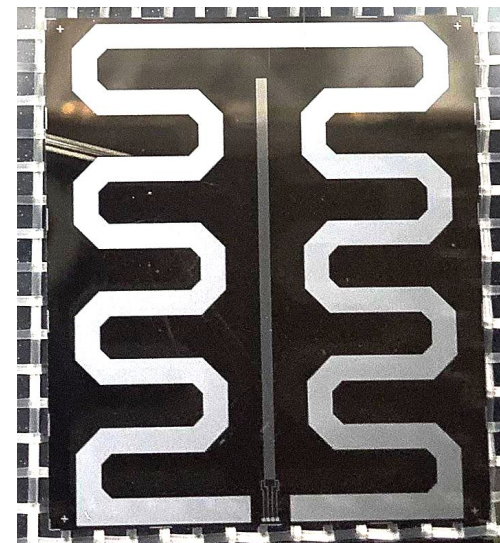
- thermal-mechanical mock-up (mechanical copy of final detector)
- silicon heater chips of final dimensions
 - 3 Ω heating loop
 - ~ 1.2 k Ω resistive thermometer
- spTAB connection to HDI



spTAB connection



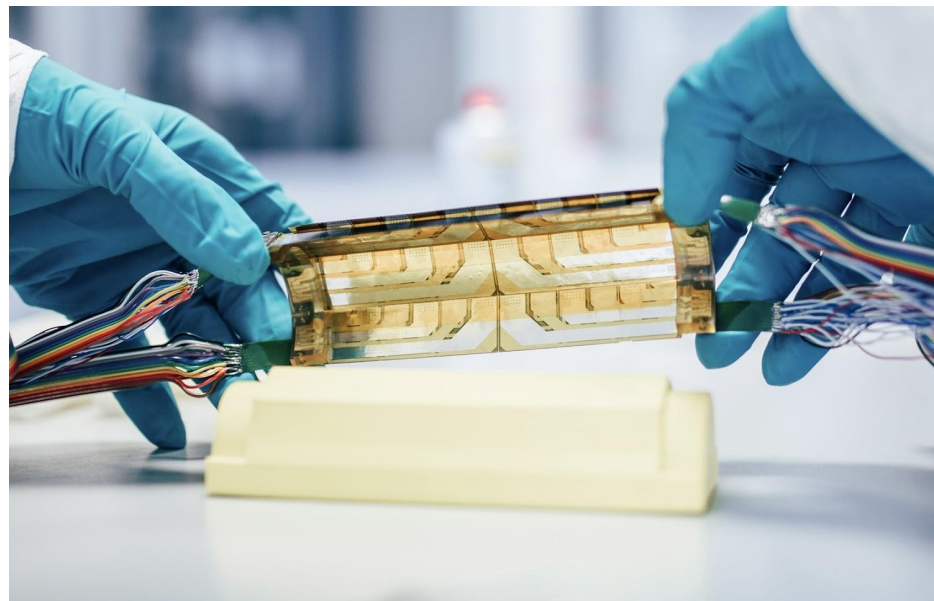
HDI for heater chips



Silicon heater chip

Cooling tests

- thermal-mechanical mock-up
- silicon heater chips of final dimensions
 - 3 Ω heating loop
 - ~ 1.2 k Ω resistive thermometer
- spTAB connection to HDI
- mock-up modules:
 - perfect matching of geometry and material
 - mounted in mini-cage with gaseous helium supply
- simulate heat loads:
 - 215 mW/cm² (expected)
 - 350 mW/cm² (conservative limit)





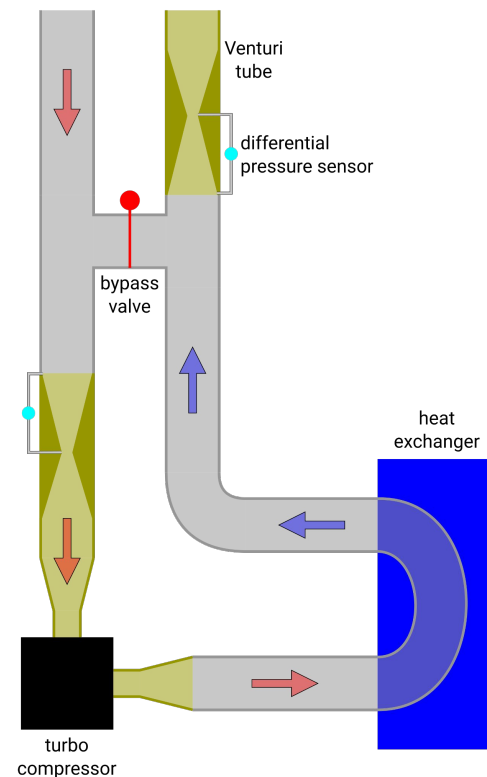
Cooling setup

- Total helium flow of 2 g/s
- Power silicon heaters with constant¹ heat load
- Readout of on-chip thermometers

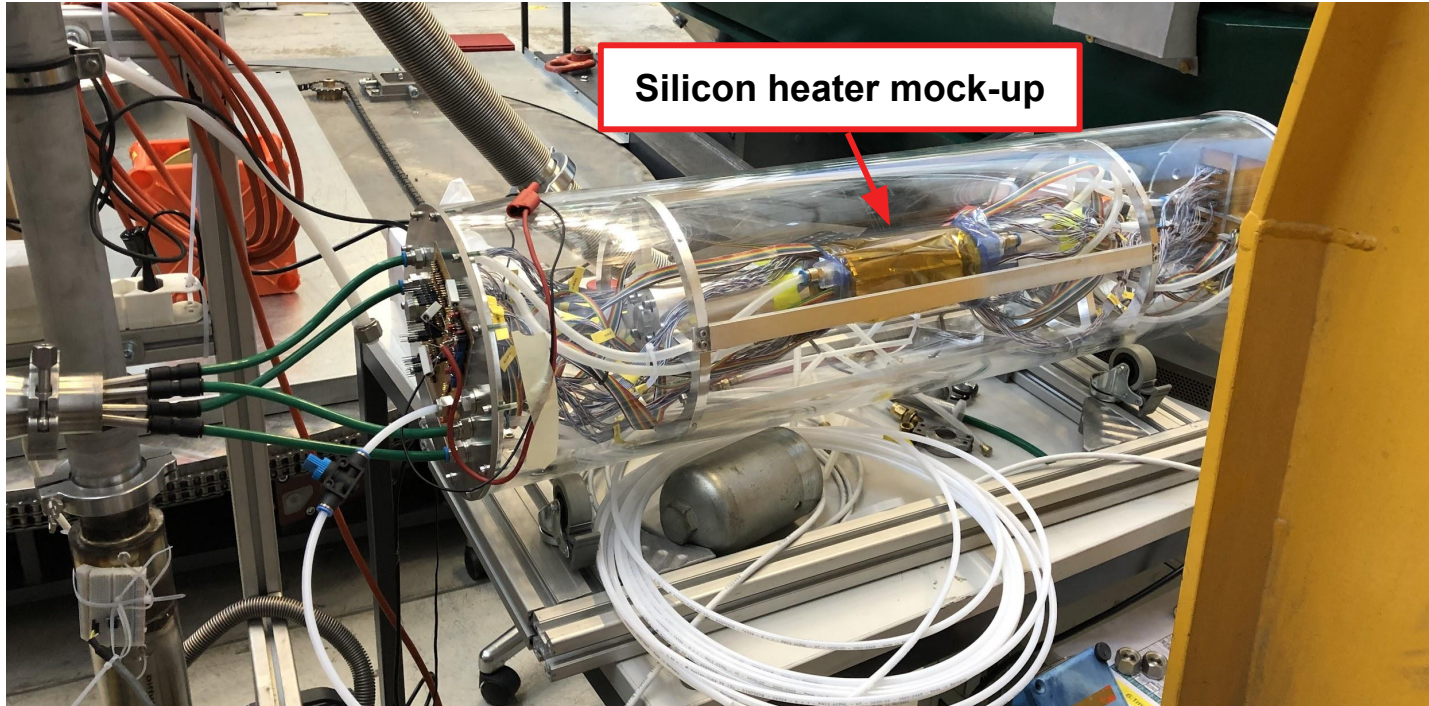
Measurements:

- transient behaviour
- temperature maps
- temperature-to-power relation

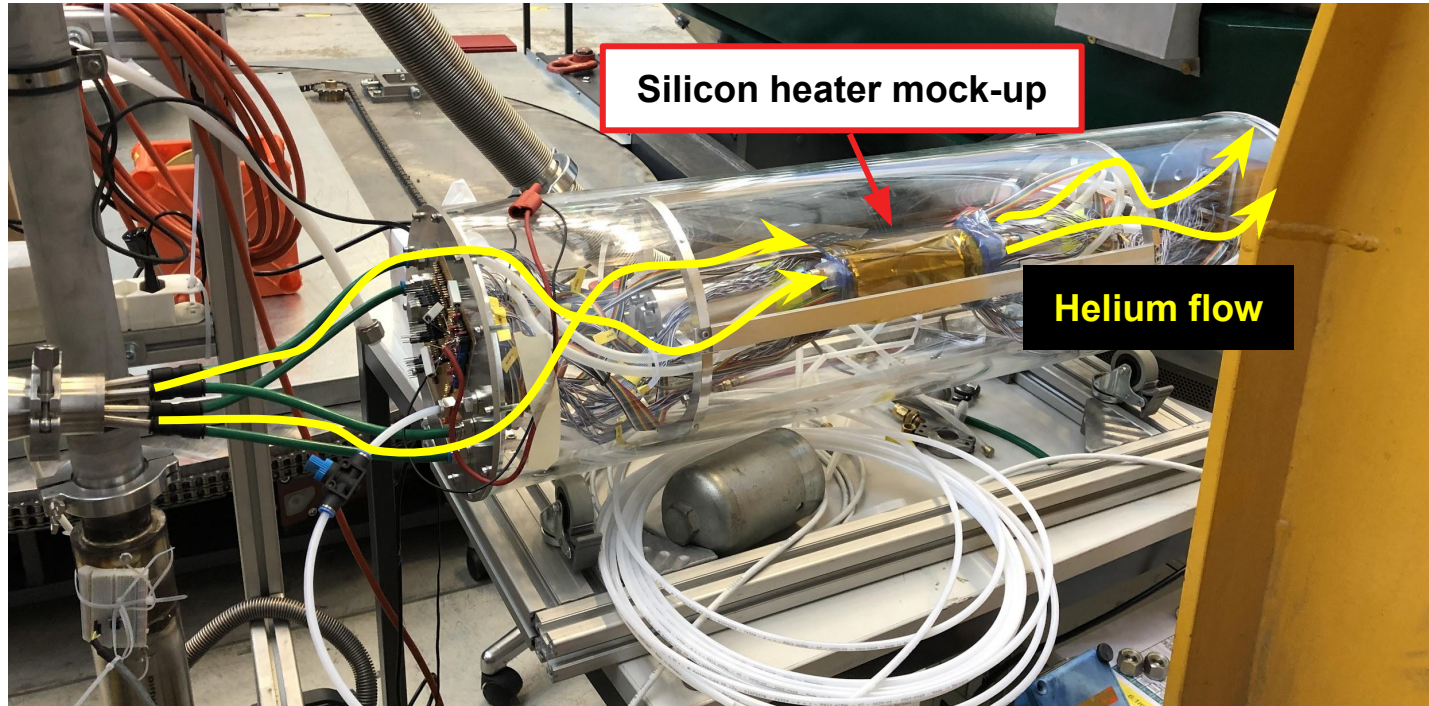
[1] heat dissipation depends on chip temperature, corrections to study uniform heating applied



Cooling setup



Cooling setup

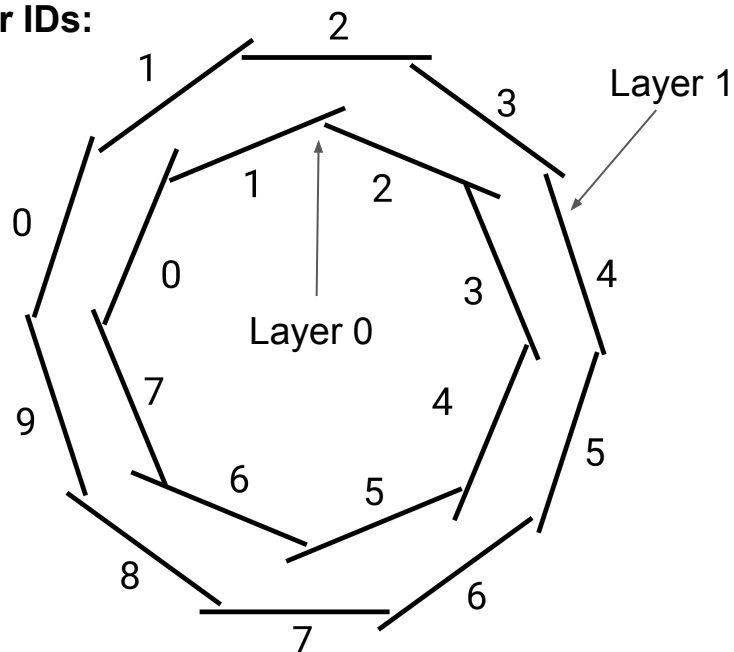




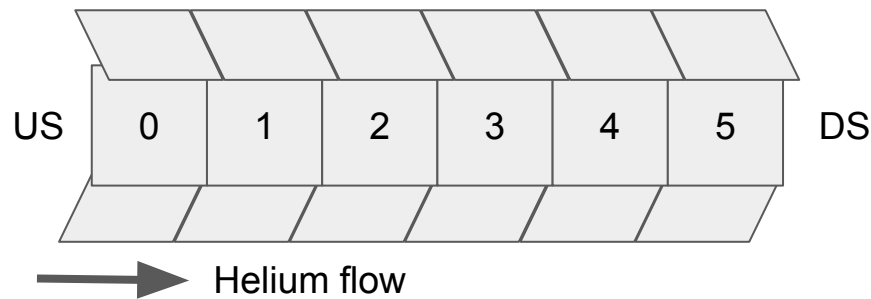
Measurement results

Numbering scheme for temperature maps (next slide)

Ladder IDs:



Chip IDs:

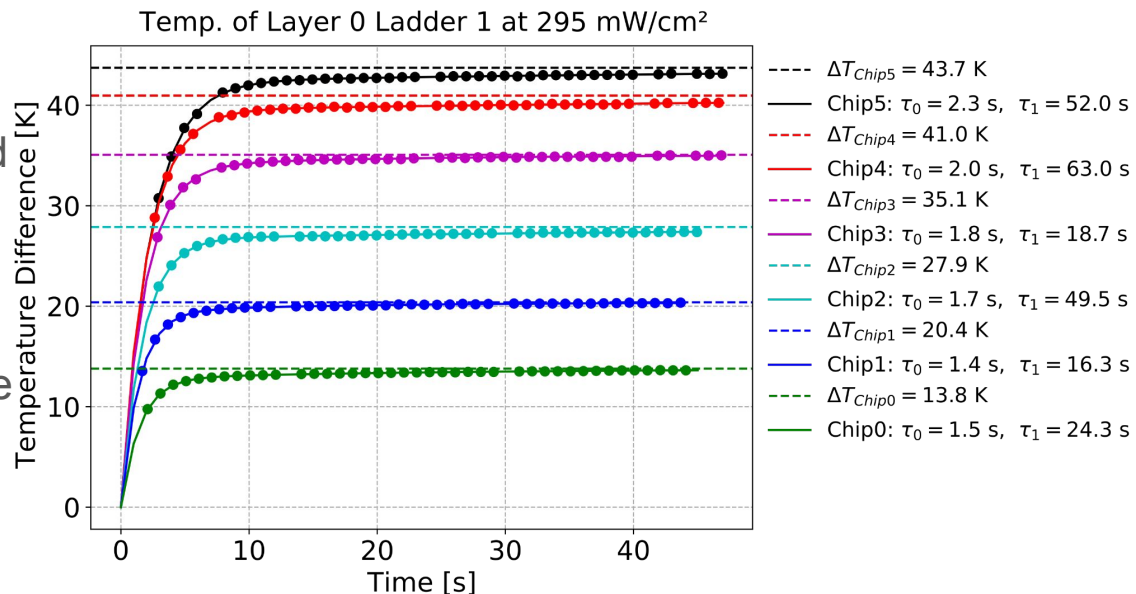




Measurement results

Transient behaviour (start-up):

- temperature increase described by 2 time constants τ_0 and τ_1
- τ_0 of 1 to 3 s
- τ_1 of 20 to 60 s
- 90 % of equilibrium temperature reached in less than 5 s
- Cooling needs to run at full speed when powering detector



Chip temperature of 1 ladder in Layer 0.
Coldest chip at gas inlet, hottest chip at outlet

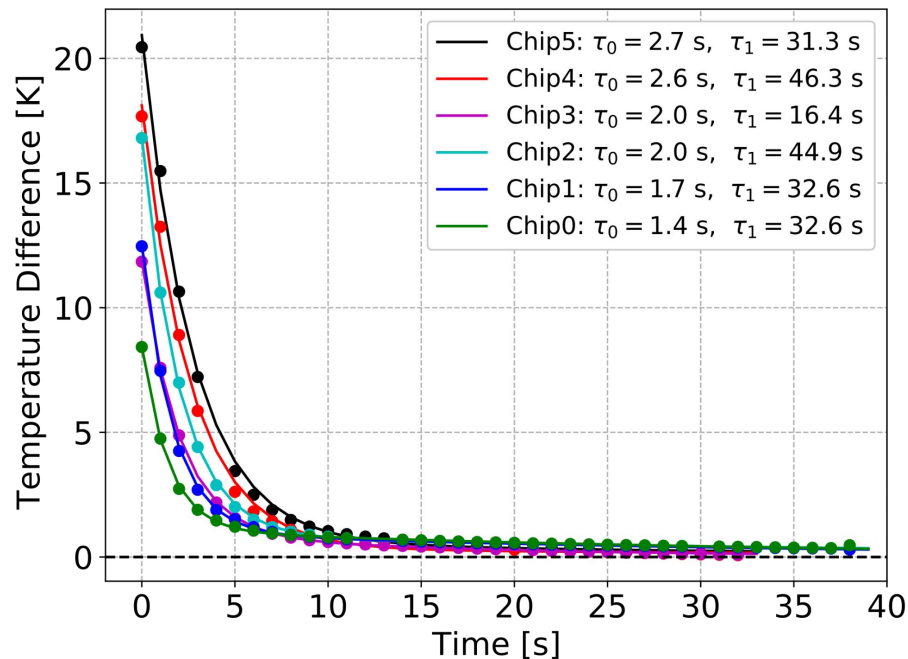


Measurement results

Transient behaviour (turning off):

- Simulated emergency shutdown of pixel power
- Similar time constants as for start-up
- $T < 5^\circ\text{C}$ in less than 5 s

Temp. of Layer 0 Ladder 1 after turning off 182 mW/cm^2

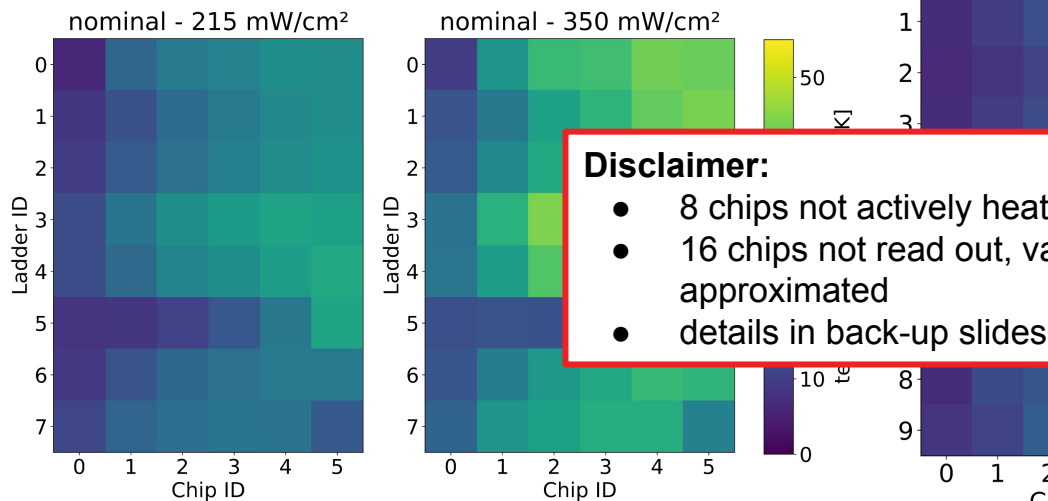




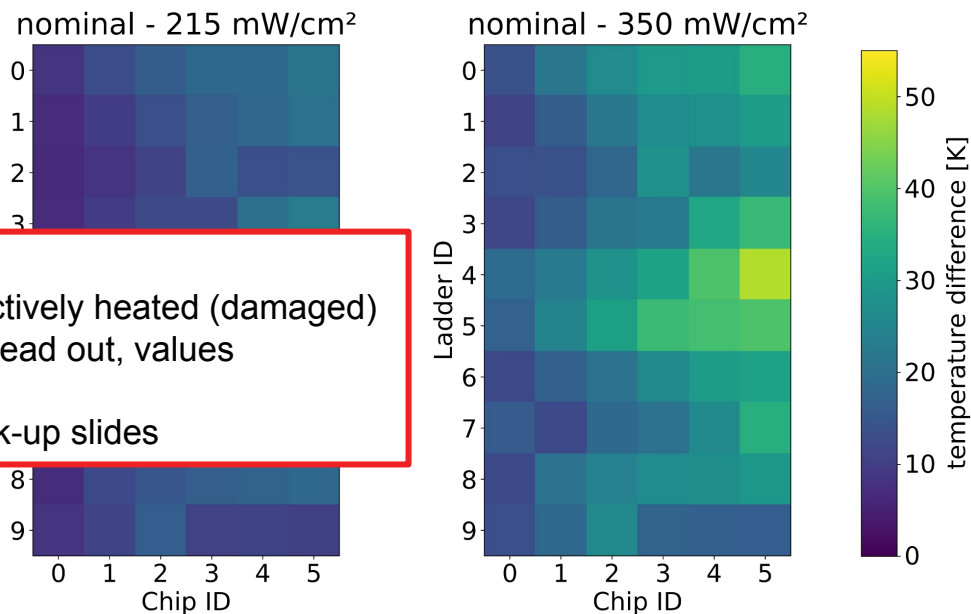
Measurement results

Temperature maps

Layer 0



Layer 1



Disclaimer:

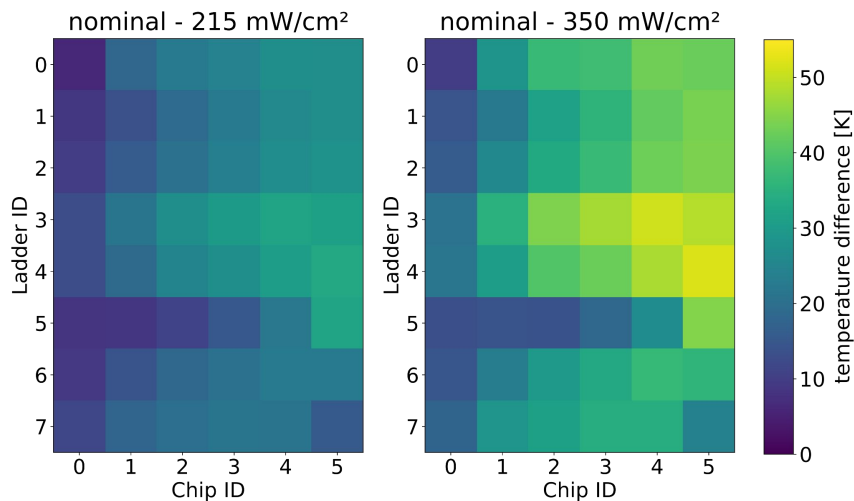
- 8 chips not actively heated (damaged)
- 16 chips not read out, values approximated
- details in back-up slides



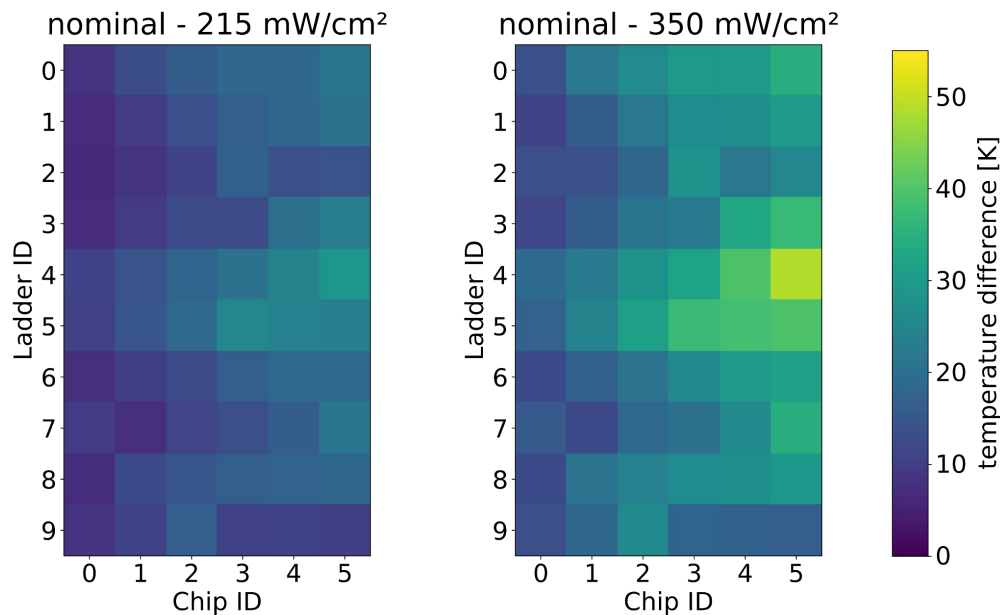
Measurement results

Temperature maps

Layer 0



Layer 1

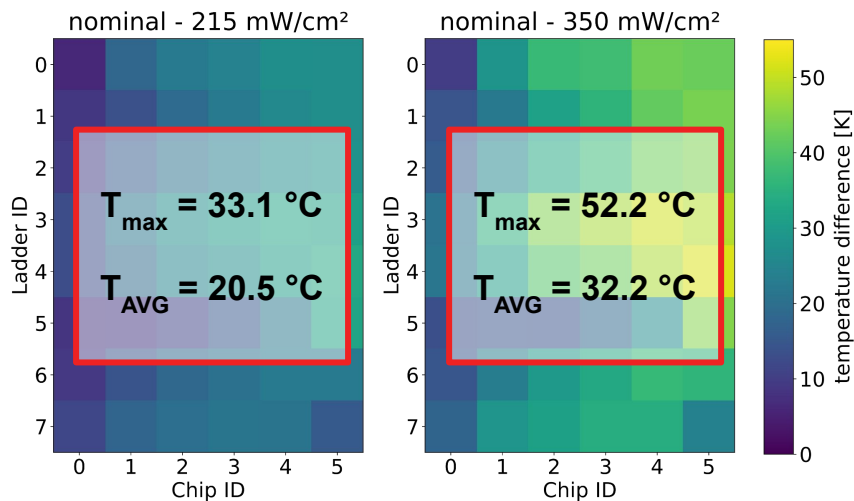




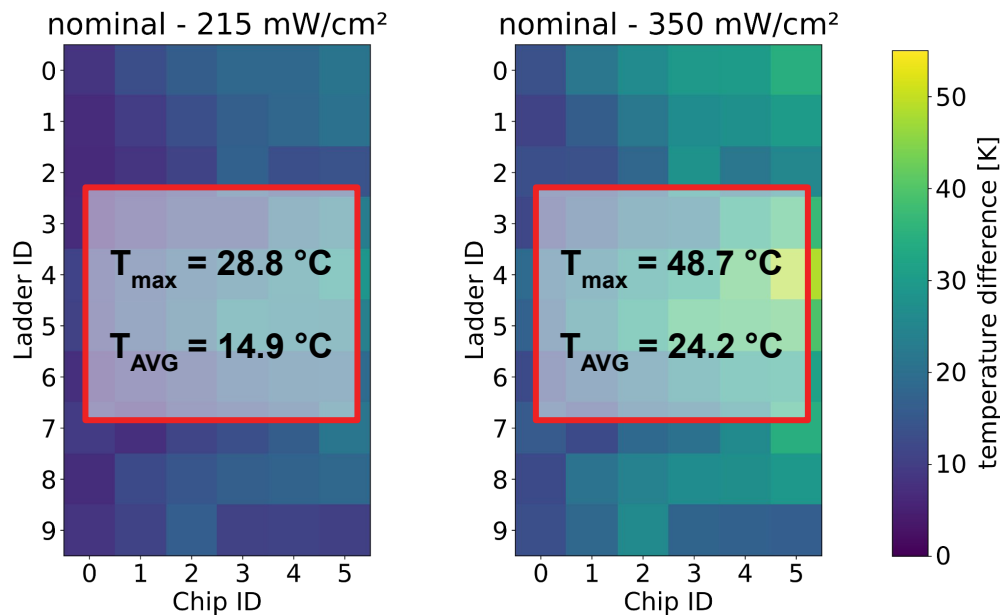
Measurement results

Temperature maps

Layer 0



Layer 1

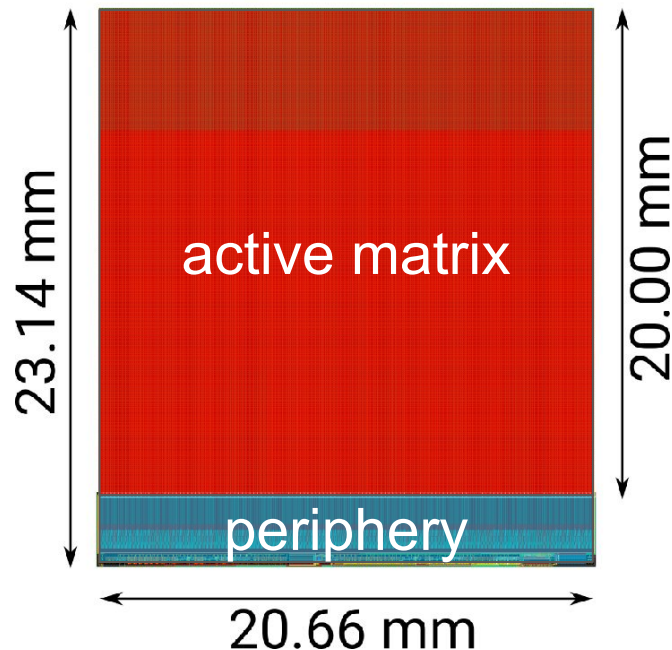




Measurement results

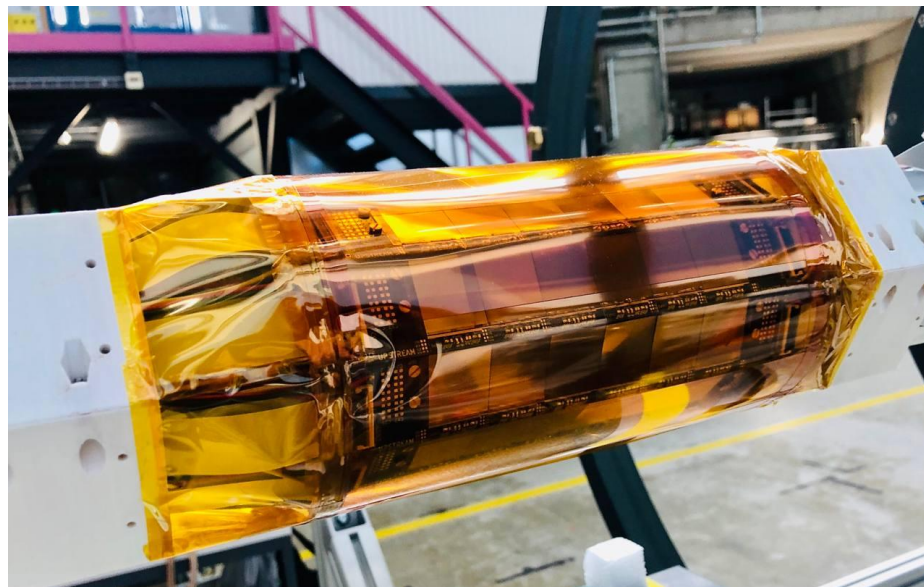
Temperature maps

- all temperatures $< 70^\circ\text{C}$
- hot area due to flow non-uniformities
- studied uniform heating
 - chip periphery of MuPix sensors will dissipate more heat than active matrix
 - 20°C higher temperatures locally expected
 - just at limit of 70°C
- 2 g/s helium cooling sufficient for Mu3e vertex detector
- at 350 mW/cm^2 at the edge of specifications



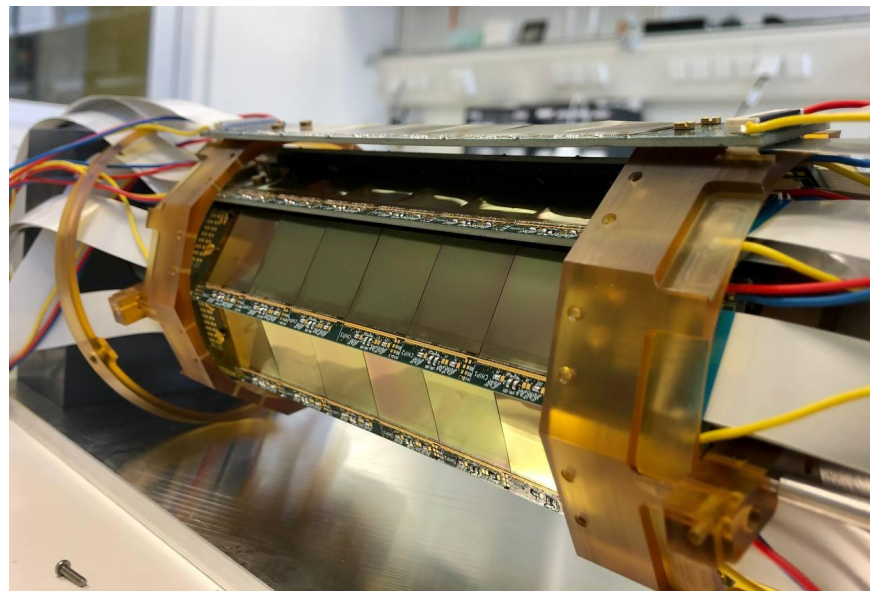
Operation of helium-cooled demonstrator

- Mu3e DAQ tests (“integration run”)
- Simplified PCB-based demonstrator
 - PCB ladders instead of HDIs
 - Full-scale MuPix10 chips
 - wire bonded chips



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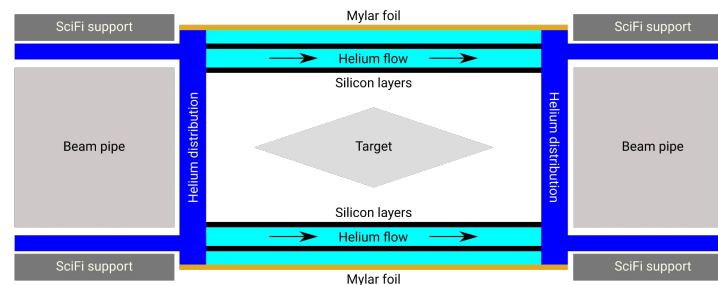




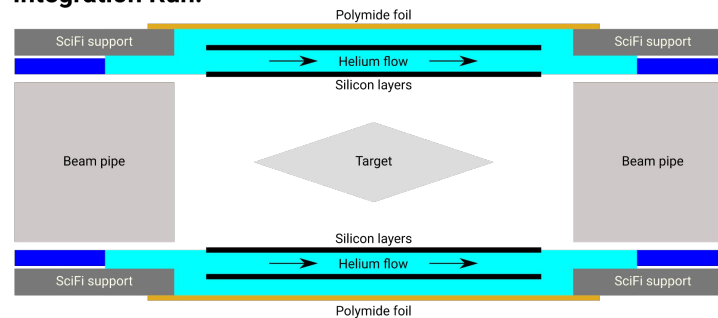
Operation of helium-cooled demonstrator

- Mu3e DAQ tests (“integration run”)
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 - Full-scale MuPix10 chips
 - wire bonded chips
- Simplified helium distribution

Phase I:



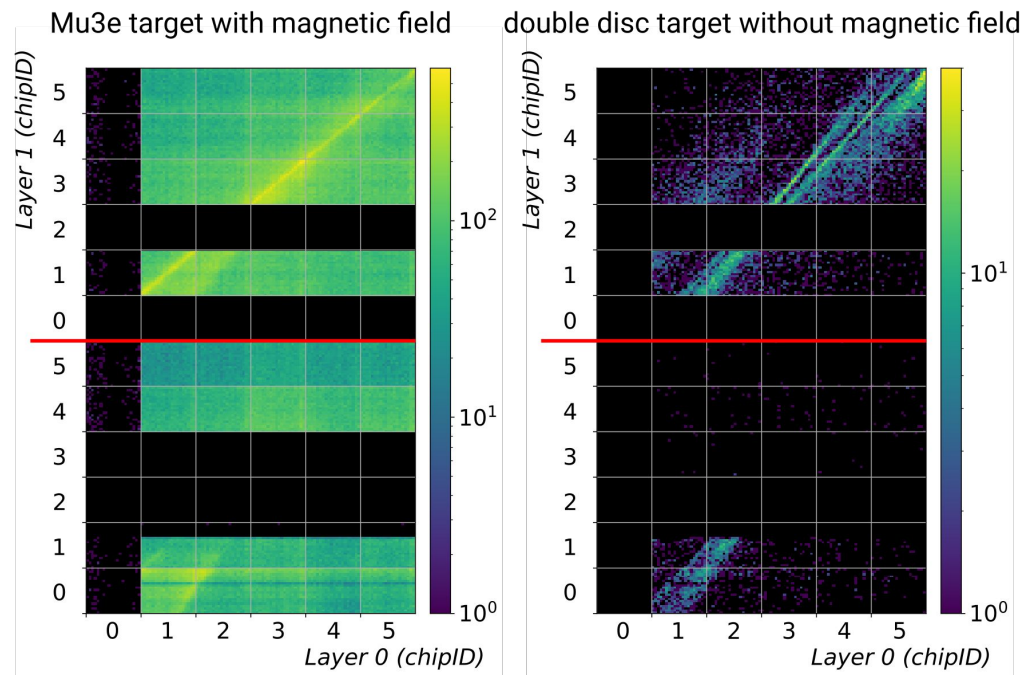
Integration Run:





Operation of helium-cooled demonstrator

- full detector operated
- ~ 100 W heat load cooled away with gaseous helium cooling (2 g/s)
- successful correlation analysis between Layer 0 and Layer 1
- Figures on the right:
 - correlating pixel hits (column address) in L0 and L1 within the same time frame (128 ns)
 - recognize geometrical features of different target configurations





Summary & Outlook

- Cooling concept verified using a detailed thermal-mechanical mock-up ✓
- Successful long-term operation with prototype helium plant (2 g/s) ✓
- First successful demonstration of operating a helium gas cooled pixel detector ✓

- Thermal tests of Mu3e outer pixel layers scheduled for late 2022
- 3x 16 g/s helium systems in production

Gaseous helium as coolant for tracking detectors aiming to minimize material:

- Material budget of $\sim 0.1\%$ per tracking layer possible when using monolithic chips and no additional support for flow channels
- Good thermal properties of helium open the possibility to use fast detectors without integrated liquid cooling systems



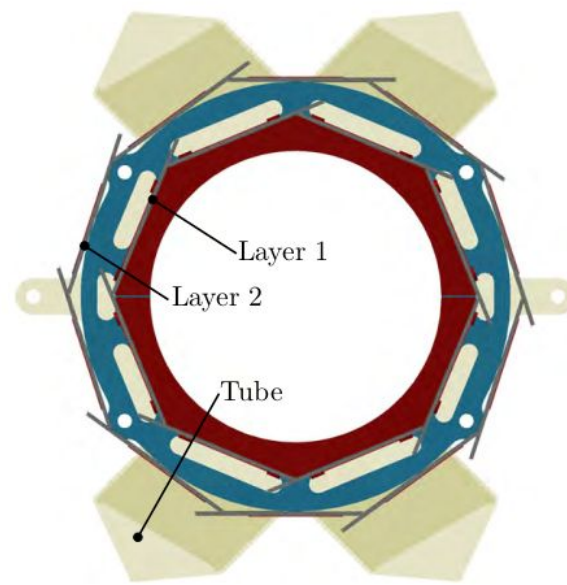
Backup



Helium distribution

Layer 1 = Layer 0; Layer 2 = Layer 1, distribution for final detector

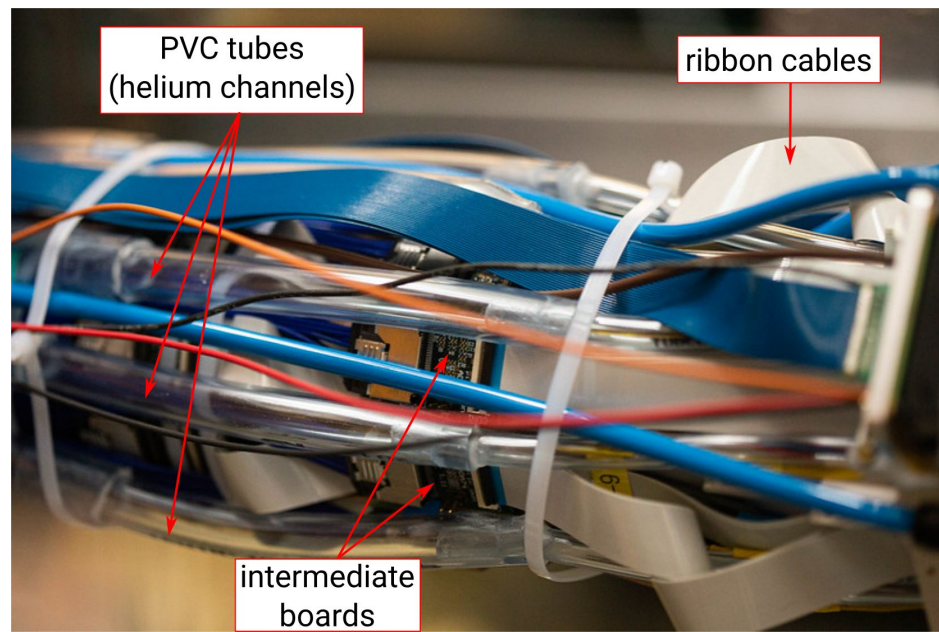
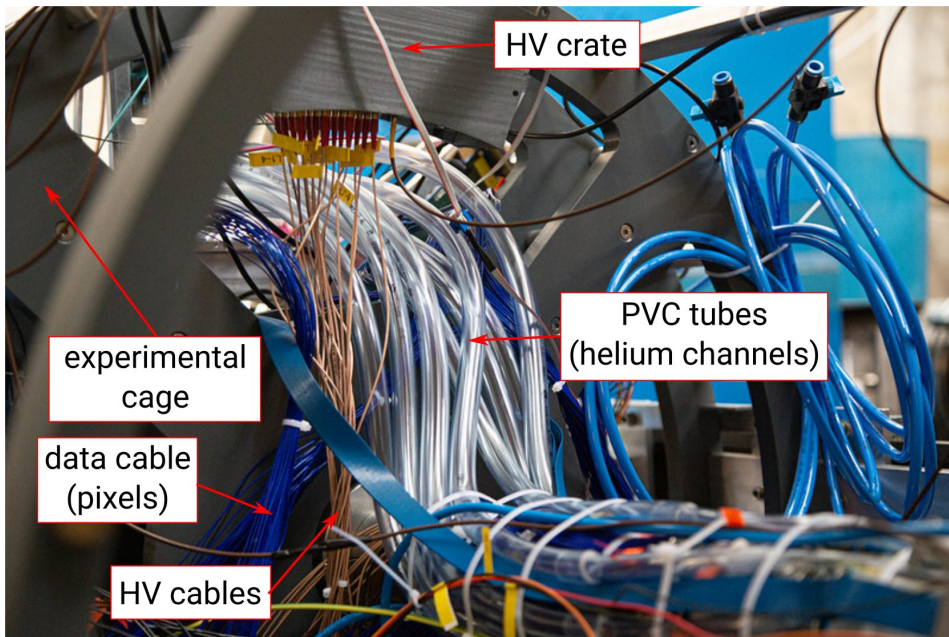
Ducts on beam pipes





Helium distribution

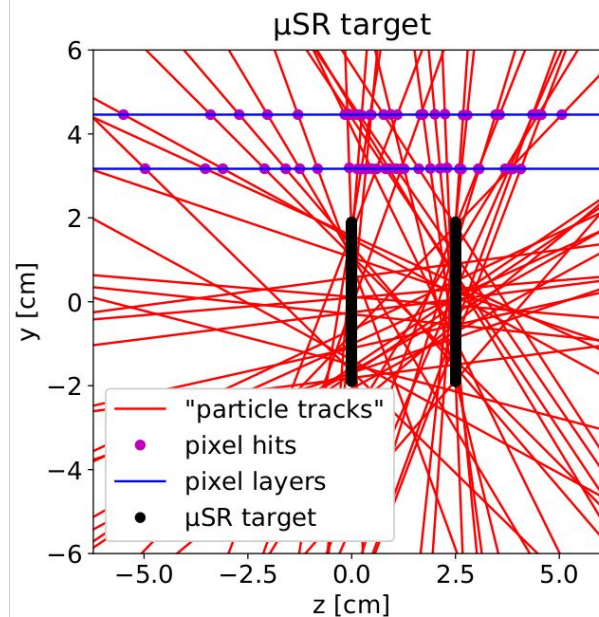
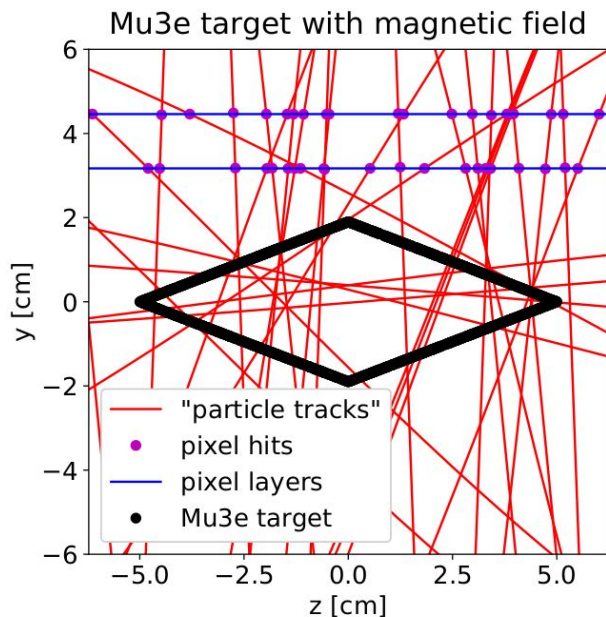
simplified helium channels for demonstrator





Target configurations - demonstrator

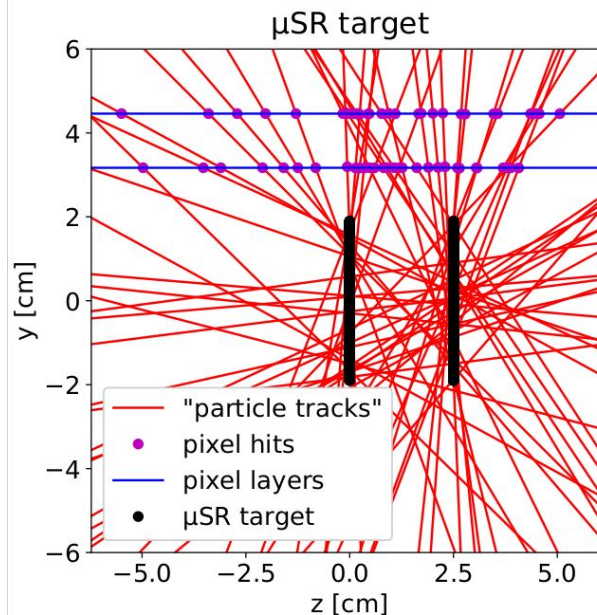
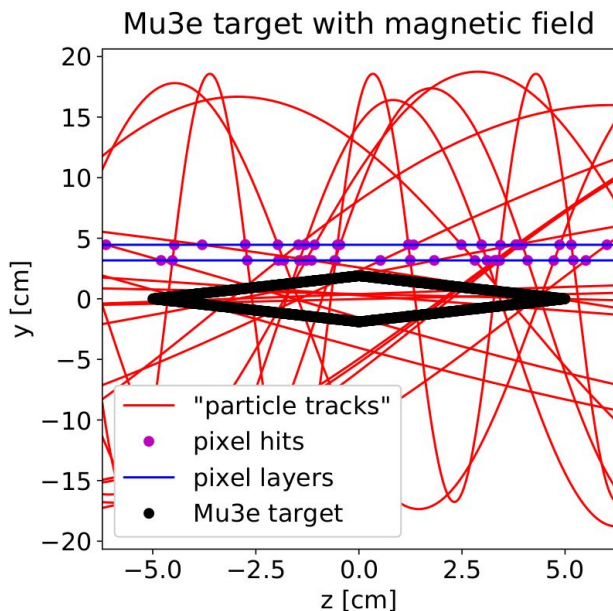
target configurations for the obtained correlation diagrams



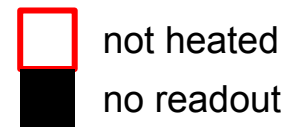


Target configurations - demonstrator

target configurations for the obtained correlation diagrams (Mu3e target zoomed-in)

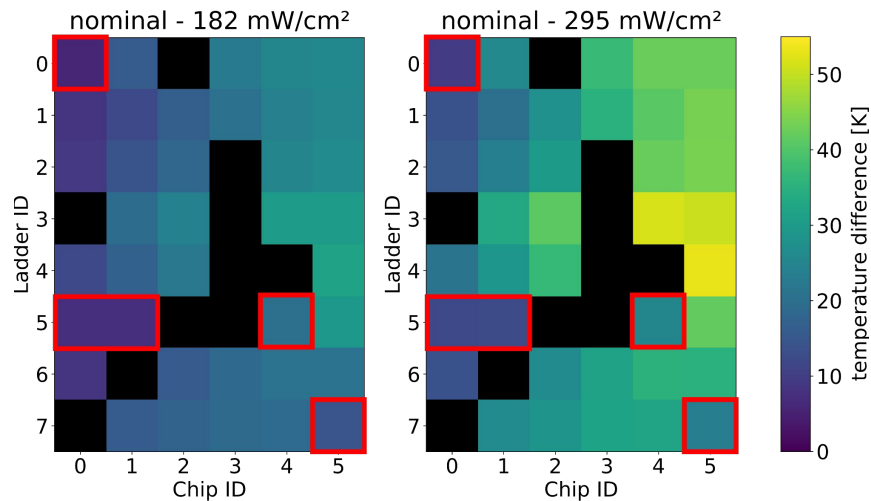


Measurement results

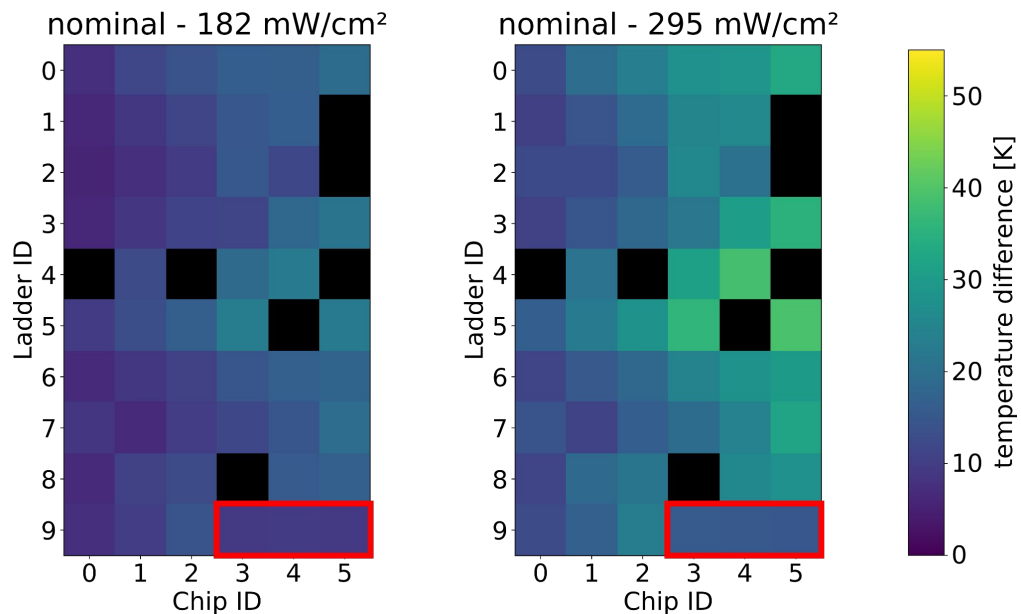


Temperature maps (raw data)


Layer 0



Layer 1



Measurement results

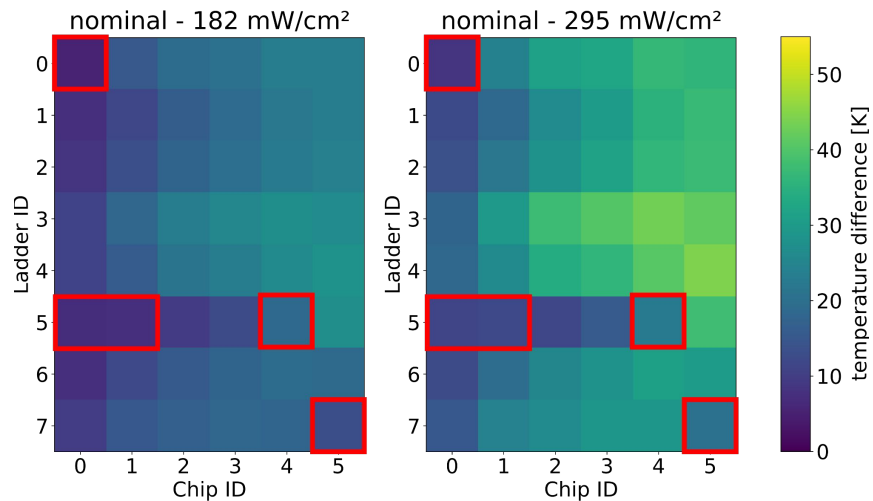
 not heated



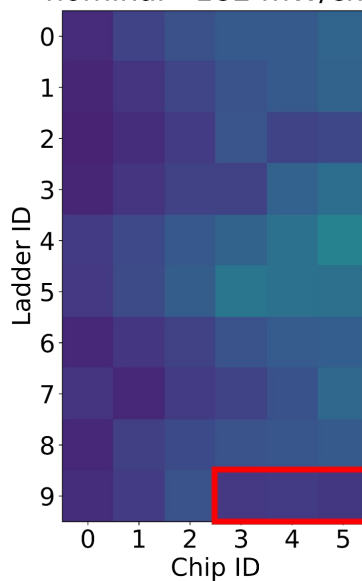
Temperature maps (raw data)

Layer 1

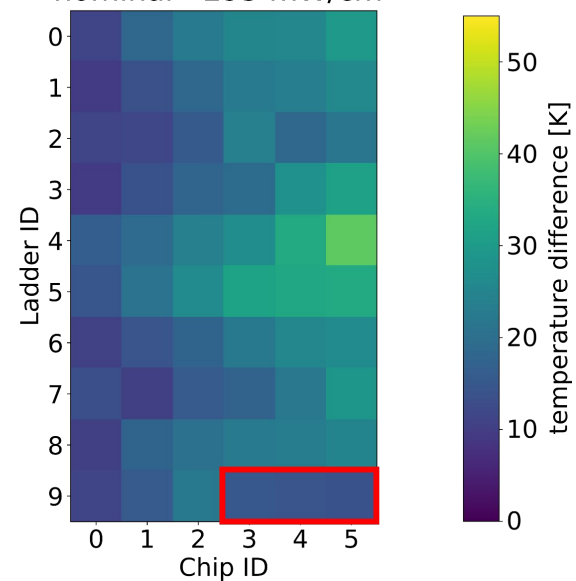
Layer 0



nominal - 182 mW/cm²



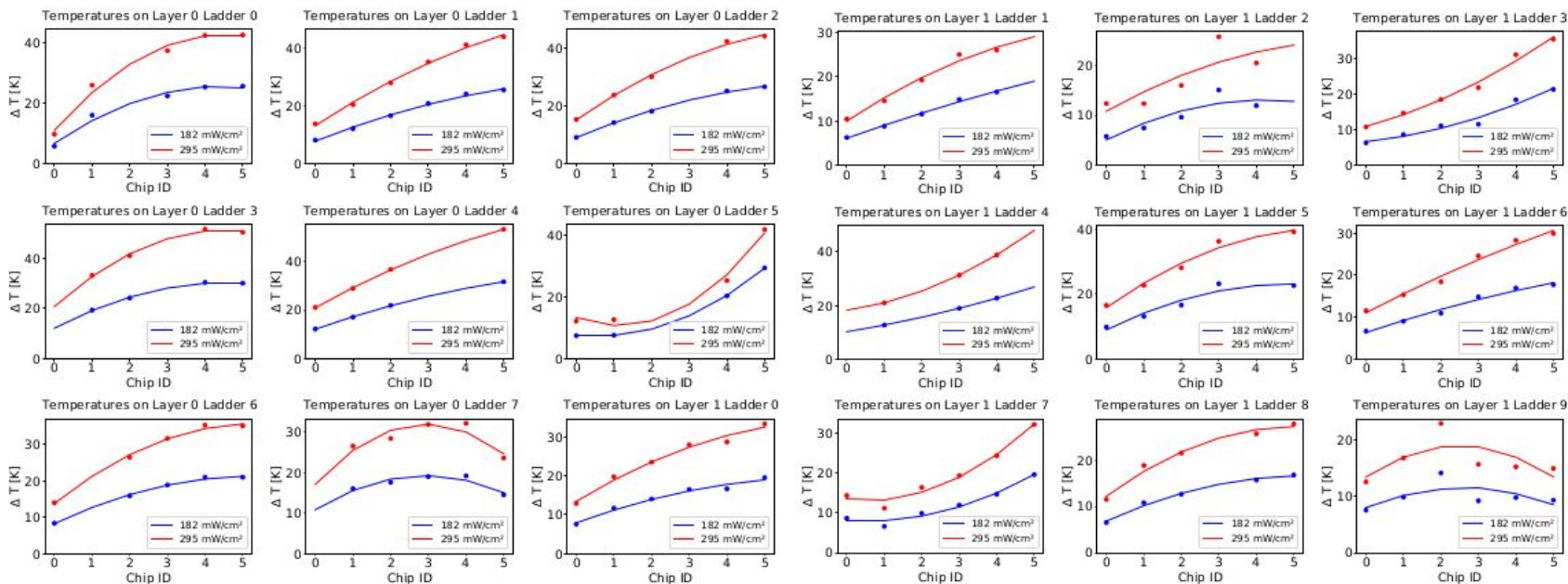
nominal - 295 mW/cm²





Measurement results

2nd order polynomial approximation of missing temperature readings:



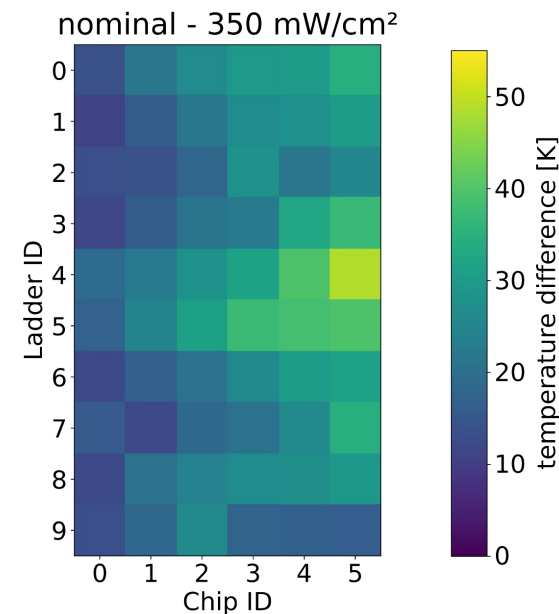
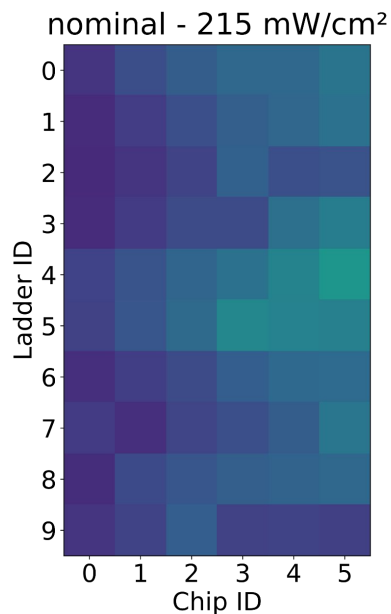
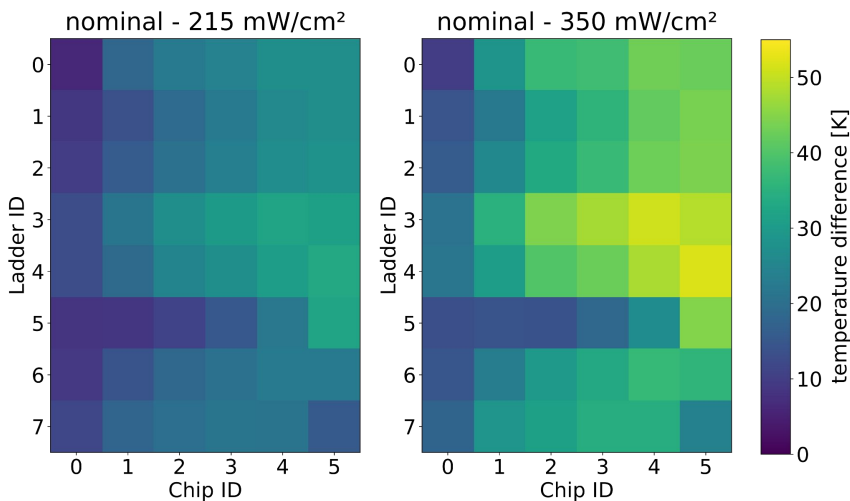


Measurement results

Temperature maps (translated to nominal heat dissipation)

Layer 1

Layer 0

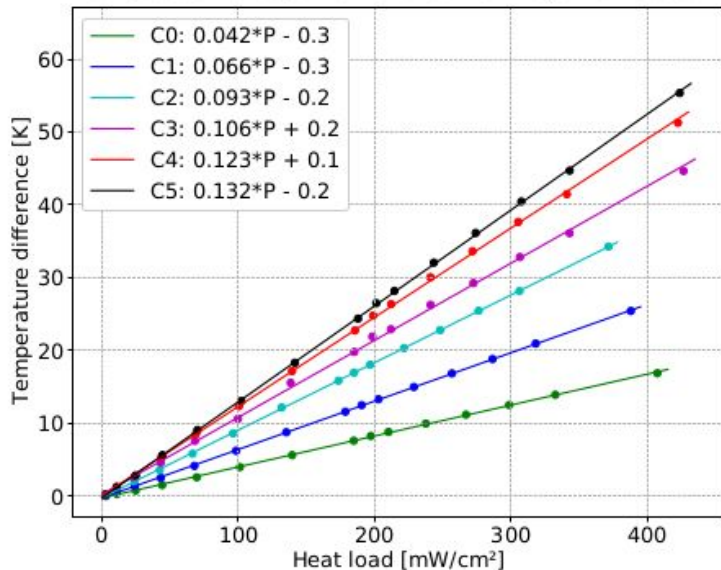




Measurement results

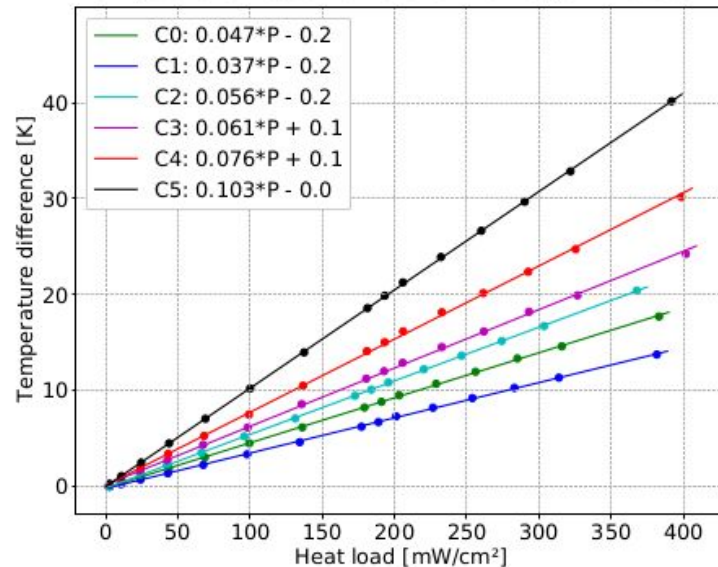
- Translation to different heat dissipation
- Linearity of temperature-to-power relation

Temperature to power relation for Layer 0 Ladder 1



C0: red. $\chi^2 = 0.22$
C1: red. $\chi^2 = 0.17$
C2: red. $\chi^2 = 0.19$
C3: red. $\chi^2 = 3.15$
C4: red. $\chi^2 = 0.91$
C5: red. $\chi^2 = 0.32$

Temperature to power relation for Layer 1 Ladder 7



C0: red. $\chi^2 = 0.07$
C1: red. $\chi^2 = 0.12$
C2: red. $\chi^2 = 0.03$
C3: red. $\chi^2 = 0.42$
C4: red. $\chi^2 = 0.67$
C5: red. $\chi^2 = 0.08$